

DEC 29 2003

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. 10/735,355
Filing Date December 12, 2003
Inventor Zhongze Wang
Assignee Micron Technology, Inc.
Group Art Unit Unassigned
Examiner Unknown
Attorney Docket No. MI22-2457
Title: Wafer Bonding Method of Forming Silicon-on-Insulator Comprising
Integrated Circuitry

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR § 1.8

I hereby certify that the following papers are being facsimile transmitted to the Patent and Trademark Office at (703) 872-9306 on the date shown below:

1. Certificate of Facsimile Transmission
2. Supplemental Information Disclosure Statement
3. Form PTO-1449 w/listed cited reference

Dated: Dec. 29, 2003

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NUMBER OF PAGES IN FACSIMILE: 3FEE DEFICIENCY

Although it is believed that no fees are due, the Commissioner is hereby authorized to charge any fees under 37 C.F.R. 1.16 and 1.17 which may be required by this paper to Deposit Account No. 23-0925.

Dated: 12-29-03

By: Mark S. Matkin
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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -See Attached Form PTO-1449

The Examiner's attention is directed to the reference which is listed on the attached Form PTO-1449. No admission is made regarding whether the reference is prior art.

Citation of the referenced art is respectfully requested.

This Supplemental Information Disclosure Statement is being filed before the mailing date of a first Office Action. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925.

Respectfully submitted,

Dated: 12-29-03

By: 

Mark S. Matkin
Reg. No. 32,268

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. M122-2457		SERIAL NO. 10/735,355	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					APPLICANT: Zhongze Wang			
					FILING DATE December 12, 2003		GROUP ART UNIT Unassigned	
U.S. PATENT DOCUMENTS								
Examiner's Initials	Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate		
AA	6,010,921	01/2000	Soutome	438	151			
AB								
AC								
AD								
AE								
AF								
AG								
AH								
AI								
FOREIGN PATENT DOCUMENTS								
	Document Number	Date	Country	Class	Subclass	Translation		
						Yes	No	
AJ								
AK								
AL								
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AM							
	AN							
	AO							
EXAMINER		DATE CONSIDERED						
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>								